

(Use several sheets if necessary)

SON-0495US

Not yet assigned

Hidehiro Matsumoto

Concurrently herewith

Not yet assigned

[illegible][illegible]

3 | 23 | 24

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

(Use several sheets if necessary)

Application Number
09/767,964

Filing Date
January 24, 2001

Group Art Unit	2152
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[illegible][illegible]

		Japanese Office Action dated May 27, 2003.

EXAMINER D. C. [Signature]

DATE CONSIDERED
3/23/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

SON-049US

Application Number

09/767,964

Applicant(s)

Hidehiro Matsumoto

Filing Date

January 24, 2001

Group Art Unit

2152

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DC		6,157,941	12/05/00	Verkler, et al.			

RECEIVED

FEB 27 2002

Technology Center 2100

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
DC		GB 2 331 600 A	05/26/99	GREAT BRITAIN				
DC		GB 2 360 423 A	09/19/01	GREAT BRITAIN				
DC		EP 1 022 894 A2	07/26/00	EUROPE				
DC		2000-148676	05/30/00	JAPAN				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

DC		United Kingdom Search Report dated October 31, 2001

EXAMINER

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3/23/04

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